



EV372470497-

UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/071,425  
Filing Date ..... February 8, 2002  
Confirmation No. .... 1727  
Inventor ..... Terry L. Gilton et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Thanhha S. Pham  
Attorney's Docket No. .... MI22-1828  
Customer No. .... 021567  
Title: Semiconductor Processing Method Using Photoresist and an Antireflective Coating

**RESPONSE TO OCTOBER 18, 2004 NOTICE OF ALLOWANCE**  
**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING**

To: Mail Stop RCE  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**VIA EXPRESS MAIL**

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)  
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*Entered  
w/ RCE  
11-2-04  
[Signature]  
5-18-05*

Responsive to the Notice of Allowance dated October 18, 2004, Applicant  
amendments and remarks as follows:

**AMENDMENTS**